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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

APPLICANTS: Jaehwan EUN, et.al.

SERIAL NO. : to be assigned

FILED : herewith

FOR : METHOD FOR PREPARING FILM STRUCTURE  
COMPRISING FERROELECTRIC SINGLE CRYSTAL LAYER

EXAMINER: to be assigned

GROUP: to be assigned

Attention: Intial Patent Examination Division  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT**

Sir:

Prior to examination, it is respectfully requested that claims 2, 5, and  
12 in the present application be amended.